Search Notes

_	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/589,590	SEVERN ET AL.	
	Examiner	Art Unit	
	Caixia Lu	1796	

	SEARCHED					
Class	Subclass	Date	Examiner			
526 5 02	160	10-26-07	a			
502	103					
	152					
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INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
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